

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Woody Tang, et. al
Assignee: Mosel Vitelic, Inc.
Title: Methods of Reducing or Removing Micromasking Residue Prior to Metal Etch Using Oxide Hardmask
Application No.: 10/649,099 Filing Date: 08/26/2003
Examiner: Dahimene, Mahmoud Group Art Unit: 1765
Docket No.: M-12977-US Confirm: 4957

San Jose, California
August 04, 2006

M/S AF

COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

AMENDMENT AFTER FINAL

Dear Sir:

In response to the Final Office Action having a mailing date of May 18, 2006, please amend the application as set forth below.

Claims Listing begins on page 2 of this paper.

Remarks begin on page 10 of this paper.

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